

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: **10/660,833** Examiner: **Juan D. Valentin**
Inventor: **Shean-Jen Chen, Chun-Yu Lin, Fan-Ching Chien, K. T. Huang, W. P. Hu, Wen-Yih Chen, Kuan-Ching Lee and Wen-Hsien Li**
Filing Date: **09/12/2003** Art Unit: **2877**
Title: **Surface Plasmon Resonance Sensor With High Sensitivity**

August 27, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT A

In response to the Office Action mailed **03/28/2007**, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Abstract begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 9 of this paper.

Petition for Extension of Time begins on page 11 of this paper.